

INFORMATION DISCLOSURE STATEMENT

Applicant : Lin et al.
 App. No : 10/807,129
 Filed : March 24, 2004
 For : INTERFERENCE DISPLAY CELL AND
 FABRICATION METHOD THEREOF
 Examiner : Lester, Evelyn A.
 Art Unit : 2873

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

May 25, 2006

(Date)


 Arthur S. Rose, Reg. No. 28,038

Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

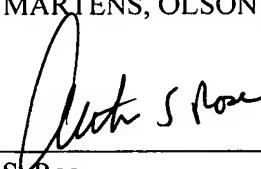
Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 442 references to be considered by the Examiner. Also enclosed are 78 foreign patent references and non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed with an RCE and no fee is required.

The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.

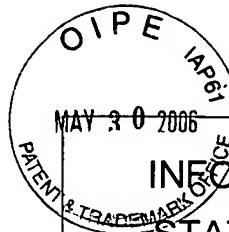
Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

By: 

Arthur S. Rose
 Registration No. 28,038
 Attorney of Record
 Customer No. 20,995
 (619) 235-8550

Dated: 5/25/06



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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Multiple sheets used when necessary)

SHEET 1 OF 15

Application No.	10/807,129
Filing Date	March 24, 2004
First Named Inventor	Wen-Jian Lin
Art Unit	2873
Examiner	LESTER, EVELYN A
Attorney Docket No.	QCO.087A / 061119

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	1.	2,534,846	12/19/50	Ambrose et al.	
	2.	2001/0026951	10/04/01	Vergani et al.	
	3.	2001/0040675	11/15/01	True et al.	
	4.	20010003487	06/14/01	Miles	
	5.	20010040649	11/15/01	Ozaki	
	6.	2002/015215	02/07/02	Miles	
	7.	2002/036304	03/28/02	Ehmke et al.	
	8.	2002/054424	5/9/2002	Miles	
	9.	2002/055253	05/09/02	Rudhard	
	10.	2002/137072	09/26/02	Mirkin et al.	
	11.	2002/168136	11/14/02	Atia et al.	
	12.	20020015215	02/07/02	Miles	
	13.	20020071169	06/13/02	Bowers et al.	
	14.	20020075555	06/20/02	Miles	
	15.	20020126364	09/12/02	Miles	
	16.	2002/0135857	09/26/02	Fitzpatrick et al.	
	17.	2002/138213	07/24/2003	Jin et al.	
	18.	2003/0006468	01/09/03	Ma et al.	
	19.	2003/0090350	05/15/03	Feng et al.	
	20.	20030043157	03/06/03	Miles	
	21.	20030062186	04/03/03	Boroson et al.	
	22.	20030072070	04/17/03	Miles	
	23.	20030152872	08/14/03	Miles, Mark W.	
	24.	20030202264	10/30/03	Weber et al.	
	25.	20030202265	10/30/03	Reboa et al.	
	26.	20030202266	10/30/03	Ring et al.	
	27.	2003/112096	06/19/2003	Potter Michael D.	
	28.	2004/0100677	05/27/04	Huibers et al.	
	29.	2004/0101115	01/15/04	Sotzing	
	30.	2004/0124073	07/2004	Pilans et al.	
	31.	2004/0125281	07/01/04	Lin et al.	
	32.	2004/136076	07/15/2004	Tayebati Parviz	
	33.	2004/0145811	07/29/04	Lin et al.	

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SHEET 2 OF 15

Application No.	10/807,129
Filing Date	March 24, 2004
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Art Unit	2873
Examiner	LESTER, EVELYN A
Attorney Docket No.	QCO.087A / 061119

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	34.	2004/0147198	07/29/04	Lin et al.	
	35.	2004/0175577	09/09/04	Lin et al.	
	36.	2004/0191937	09/30/04	Patel et al.	
	37.	2004/0207897	10/21/04	Lin	
	38.	2004/0209192	10/21/04	Lin et al.	
	39.	2004/0209195	10/21/04	Lin	
	40.	2004/0240027	12/02/04	Lin et al.	
	41.	2004/027636	02/12/04	Miles	
	42.	2004/027701	2/12/2004	Ishikawa	
	43.	2004/051929	03/18/04	Sampsell et al.	
	44.	2004/053434	03/18/04	Bruner	
	45.	2004/058532	03/25/04	Miles et al.	
	46.	2004/063322	04/01/2004	Yang	
	47.	2004/125282	7/1/2004	Lin et al.	
	48.	20040028849	02/12/04	Stark et al.	
	49.	20040035821	02/26/04	Doan et al.	
	50.	20040051929	03/18/04	Sampsell et al.	
	51.	20040058532	03/25/04	Miles et al.	
	52.	20040061543	04/01/04	Nam et al.	
	53.	20040080807	04/29/04	Chen et al.	
	54.	2004/080832	04/29/2004	Singh Mandeep	
	55.	20040145049	07/29/04	McKinnell et al.	
	56.	20040147056	07/29/04	McKinnell et al.	
	57.	20040150869	08/05/04	Kasai, Hiroto	
	58.	20040160143	08/19/04	Shreeve et al.	
	59.	20040174583	09/09/04	Chen et al.	
	60.	20040179281	09/16/04	Reboa	
	61.	20040212026	10/28/04	Van Brocklin et al.	
	62.	20040217378	11/04/04	Martin et al.	
	63.	20040217919	11/04/04	Pichl et al.	
	64.	20040218251	11/04/04	Pichl et al.	
	65.	20040218334	11/04/04	Martin et al.	
	66.	20040218341	11/04/04	Martin et al.	
	67.	20040227493	11/18/04	Van Brocklin et al.	

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SHEET 3 OF 15

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Art Unit	2873
Examiner	LESTER, EVELYN A
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	68.	20040240032	12/02/04	Miles	
	69.	20040240138	12/02/04	Martin et al.	
	70.	20040245588	12/09/04	Nikkel et al.	
	71.	20040263944	12/30/04	Miles et al.	
	72.	2005/0003667	01/06/05	Lin et al.	
	73.	2005/0020089	01/27/05	Shi et al.	
	74.	2005/0024557	02/03/05	Lin	
	75.	2005/0035699	02/17/05	Tsai	
	76.	2005/0036095	02/17/05	Yeh et al.	
	77.	2005/0036192	02/17/05	Lin et al.	
	78.	2005/0042117	02/24/05	Lin	
	79.	2005/0046922	03/03/05	Lin et al.	
	80.	2005/0046948	03/03/05	Lin	
	81.	2005/0068605	03/31/05	Tsai	
	82.	2005/0068606	03/31/05	Tsai	
	83.	2005/0078348	04/14/05	Lin	
	84.	2005/0168849	08/04/05	Lin	
	85.	2005/0195462	09/08/05	Lin	
	86.	2005/0202649	09/15/05	Hung et al.	
	87.	20050001828	01/06/05	Martin et al.	
	88.	20050038950	02/17/05	Adelmann	
	89.	20050057442	03/17/05	Way	
	90.	20050068583	03/31/05	Gutkowski et al.	
	91.	20050069209	03/31/05	Damera-Venkata et al.	
	92.	3,439,973	04/22/69	Paul et al.	
	93.	3,443,854	05/13/69	Weiss	
	94.	3,653,741	04/04/72	Marks	
	95.	3,656,836	04/18/72	de Cremoux et al.	
	96.	3,725,868	04/03/73	Malmer, Jr. et al.	
	97.	3,813,265	05/28/74	Marks	
	98.	3,955,880	05/11/76	Lierke	
	99.	4,099,854	07/11/78	Decker et al.	
	100.	4,196,396	04/01/80	Smith	
	101.	4,228,437	10/14/80	Shelton	

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PTO/SB/08 Equivalent

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Multiple sheets used when necessary)		Application No.	10/807,129
		Filing Date	March 24, 2004
		First Named Inventor	Wen-Jian Lin
		Art Unit	2873
SHEET 4 OF 15		Examiner	LESTER, EVELYN A
		Attorney Docket No.	QCO.087A / 061119

U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	102.	4,377,324	03/22/83	Durand et al.	
	103.	4,389,096	06/21/83	Hori et al.	
	104.	4,403,248	09/06/83	te Velde	
	105.	4,441,791	04/10/84	Hornbeck	
	106.	4,445,050	04/24/84	Marks	
	107.	4,459,182	07/10/84	te Velde	
	108.	4,482,213	11/13/84	Piliavin et al.	
	109.	4,500,171	02/19/85	Penz et al.	
	110.	4,519,676	05/28/85	te Velde	
	111.	4,531,126	07/23/85	Sadones	
	112.	4,566,935	01/28/86	Hornbeck	
	113.	4,571,603	02/18/86	Hornbeck et al.	
	114.	4,596,992	06/24/86	Hornbeck	
	115.	4,615,595	10/07/86	Hornbeck	
	116.	4,662,746	05/05/87	Hornbeck	
	117.	4,663,083	05/05/87	Marks	
	118.	4,681,403	07/21/87	te Velde et al.	
	119.	4,710,732	12/01/87	Hornbeck	
	120.	4,748,366	05/31/88	Taylor	
	121.	4,786,128	11/22/88	Birnbach	
	122.	4,790,635	12/13/88	Apsley	
	123.	4,856,863	08/15/89	Sampsell et al.	
	124.	4,937,496	06/26/90	Neiger et al.	
	125.	4,954,789	09/04/90	Sampsell	
	126.	4,956,619	09/11/90	Hornbeck	
	127.	4,982,184	01/01/91	Kirkwood	
	128.	5,018,256	05/28/91	Hornbeck	
	129.	5,022,745	06/11/91	Zahowski et al.	
	130.	5,028,939	07/02/91	Hornbeck et al.	
	131.	5,037,173	08/06/91	Sampsell et al.	
	132.	5,044,736	09/03/91	Jaskie et al.	
	133.	5,061,049	10/29/91	Hornbeck	
	134.	5,075,796	12/24/91	Schildkraut et al.	
	135.	5,078,479	01/07/92	Vuilleumier	

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SHEET 5 OF 15

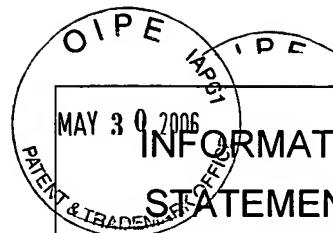
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Filing Date	March 24, 2004
First Named Inventor	Wen-Jian Lin
Art Unit	2873
Examiner	LESTER, EVELYN A
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U.S. PATENT DOCUMENTS

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	136.	5,079,544	01/07/92	DeMond et al.	
	137.	5,083,857	01/28/92	Hornbeck	
	138.	5,096,279	03/17/92	Hornbeck et al.	
	139.	5,099,353	03/24/92	Hornbeck	
	140.	5,124,834	06/23/92	Cusano et al.	
	141.	5,136,669	08/04/92	Gerdt	
	142.	5,142,405	08/25/92	Hornbeck	
	143.	5,142,414	08/25/92	Koehler	
	144.	5,153,771	10/06/92	Link et al.	
	145.	5,162,787	11/10/92	Thompson et al.	
	146.	5,168,406	12/01/92	Nelson	
	147.	5,170,156	12/08/92	DeMond et al.	
	148.	5,172,262	12/15/92	Hornbeck	
	149.	5,179,274	01/12/93	Sampsell	
	150.	5,192,395	03/09/93	Boysel et al.	
	151.	5,192,946	03/09/93	Thompson et al.	
	152.	5,206,629	04/27/93	DeMond et al.	
	153.	5,214,419	05/25/93	DeMond et al.	
	154.	5,214,420	05/25/93	Thompson et al.	
	155.	5,216,537	06/01/93	Hornbeck	
	156.	5,226,099	07/06/93	Mignardi et al.	
	157.	5,228,013	07/13/93	Bik	
	158.	5,231,532	07/27/93	Magel et al.	
	159.	5,233,385	08/03/93	Sampsell	
	160.	5,233,456	08/03/93	Nelson	
	161.	5,233,459	08/03/93	Bozler et al.	
	162.	5,254,980	10/19/93	Hendrix et al.	
	163.	5,272,473	12/21/93	Thompson et al.	
	164.	5,278,652	01/11/94	Urbanus et al.	
	165.	5,280,277	01/18/94	Hornbeck	
	166.	5,287,096	02/15/94	Thompson et al.	
	167.	5,296,950	03/22/94	Lin et al.	
	168.	5,299,041	03/29/94	Morin et al.	
	169.	5,305,640	04/26/94	Boysel et al.	

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	170.	5,311,360	05/10/94	Bloom et al.	
	171.	5,312,513	05/17/94	Florence et al.	
	172.	5,323,002	06/21/94	Sampsell et al.	
	173.	5,324,683	06/28/94	Fitch et al.	
	174.	5,325,116	06/28/94	Sampsell	
	175.	5,326,430	07/05/94	Cronin et al.	
	176.	5,327,286	07/05/94	Sampsell et al.	
	177.	5,331,454	07/19/94	Hornbeck	
	178.	5,339,116	08/16/94	Urbanus et al.	
	179.	5,345,328	09/06/94	Fritz et al.	
	180.	5,365,283	11/15/94	Doherty et al.	
	181.	5,381,232	01/10/95	van Wijk	
	182.	5,381,253	01/10/95	Sharp et al.	
	183.	5,401,983	03/28/95	Jokerst et al.	
	184.	5,411,769	05/02/95	Hornbeck	
	185.	5,444,566	08/22/95	Gale et al.	
	186.	5,446,479	08/29/95	Thompson et al.	
	187.	5,448,314	09/05/95	Heimbuch et al.	
	188.	5,452,024	09/19/95	Sampsell	
	189.	5,454,906	10/03/95	Baker et al.	
	190.	5,457,493	10/10/95	Leddy et al.	
	191.	5,457,566	10/10/95	Sampsell et al.	
	192.	5,459,602	10/17/95	Sampsell	
	193.	5,459,610	10/17/95	Bloom et al.	
	194.	5,461,411	10/24/95	Florence et al.	
	195.	5,489,952	02/06/96	Gove et al.	
	196.	5,497,172	03/05/96	Doherty et al.	
	197.	5,497,197	03/05/96	Gove et al.	
	198.	5,499,062	03/12/96	Urbanus	
	199.	5,500,635	03/19/96	Mott	
	200.	5,500,761	03/19/96	Goossen et al.	
	201.	5,503,952	04/02/96	Suzuki et al.	
	202.	5,506,597	04/09/96	Thompson et al.	
	203.	5,515,076	05/07/96	Thompson et al.	

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SHEET 7 OF 15

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	204.	5,517,347	05/14/96	Sampsell	
	205.	5,523,803	06/04/96	Urbanus et al.	
	206.	5,526,051	06/11/96	Gove et al.	
	207.	5,526,172	06/11/96	Kanack	
	208.	5,526,327	06/11/96	Cordova, Jr.	
	209.	5,526,688	06/18/96	Boysel et al.	
	210.	5,535,047	07/09/96	Hornbeck	
	211.	5,548,301	08/20/96	Kornher et al.	
	212.	5,551,293	09/03/96	Boysel et al.	
	213.	5,552,924	09/03/96	Tregilgas	
	214.	5,552,925	09/03/96	Worley	
	215.	5,559,358	09/24/96	Burns et al.	
	216.	5,563,398	10/08/96	Sampsell	
	217.	5,567,334	10/22/96	Baker et al.	
	218.	5,570,135	10/29/96	Gove et al.	
	219.	5,579,149	11/26/96	Moret et al.	
	220.	5,581,272	12/03/96	Conner et al.	
	221.	5,583,688	12/10/96	Hornbeck	
	222.	5,589,852	12/31/96	Thompson et al.	
	223.	5,597,736	01/28/97	Sampsell	
	224.	5,600,383	02/04/97	Hornbeck	
	225.	5,602,671	02/11/97	Hornbeck	
	226.	5,606,441	02/25/97	Florence et al.	
	227.	5,608,468	03/04/97	Gove et al.	
	228.	5,610,438	03/11/97	Wallace et al.	
	229.	5,610,624	03/11/97	Bhuva	
	230.	5,610,625	03/11/97	Sampsell	
	231.	5,619,059	04/08/97	Li et al.	
	232.	5,619,365	04/08/97	Rhoades et al.	
	233.	5,619,366	04/08/97	Rhoades et al.	
	234.	5,622,814	04/22/97	Miyata et al.	
	235.	5,629,790	05/13/97	Neukermans et al.	
	236.	5,633,652	05/27/97	Kanbe et al.	
	237.	5,636,052	06/03/97	Arney et al.	

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(Multiple sheets used when necessary)

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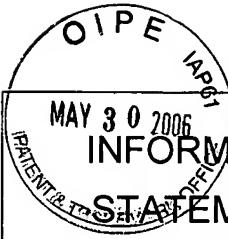
Application No.	10/807,129
Filing Date	March 24, 2004
First Named Inventor	Wen-Jian Lin
Art Unit	2873
Examiner	LESTER, EVELYN A
Attorney Docket No.	QCO.087A / 061119

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	238.	5,636,185	06/03/97	Brewer et al.	
	239.	5,638,084	06/10/97	Kalt	
	240.	5,638,946	06/17/97	Zavracky	
	241.	5,641,391	06/24/97	Hunter et al.	
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	255.	5,739,945	04/14/98	Tayebati	
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Application No.	10/807,129
Filing Date	March 24, 2004
First Named Inventor	Wen-Jian Lin
Art Unit	2873
Examiner	LESTER, EVELYN A
Attorney Docket No.	QCO.087A / 061119

U.S. PATENT DOCUMENTS

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	275.	5,986,796	11/16/99	Miles	
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	277.	6,038,056	03/14/00	Florence et al.	
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Application No.	10/807,129
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	308.	6,473,274	10/29/02	Maimone et al.	
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**INFORMATION DISCLOSURE
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Application No.	10/807,129
Filing Date	March 24, 2004
First Named Inventor	Wen-Jian Lin
Art Unit	2873
Examiner	LESTER, EVELYN A
Attorney Docket No.	QCO.087A / 061119

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	365.	CH 681 047	12-31-1992	Landis & GYR Betriebs AG		
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	367.	EP 0 667 548 A1	08-16-1995	AT&T Corporation		
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Examiner Signature

Date Considered

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		Filing Date	March 24, 2004
		First Named Inventor	Wen-Jian Lin
		Art Unit	2873
(Multiple sheets used when necessary)		Examiner	LESTER, EVELYN A
SHEET 12 OF 15		Attorney Docket No.	QCO.087A / 061119

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Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹
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Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹
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	429.	PCT/US05/033558 Partial International Search Report (02/24/06)	
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Examiner Signature	Date Considered
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¹ - Place a check mark in this area when an English language Translation is attached.